

Atty.
Dkt. No.

Mr.

Client Ref.

242977

D855

**INFORMATION DISCLOSURE STATEMENT
BY APPLICANT**



Applicant: VANDEBERG

Appln. No.: 09/040,336

Filing Date: August 18, 2000

Date: August 18, 2000

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Examiner: Ngo

Group Art Unit: 2874

U.S. PATENT DOCUMENTS

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
hn	AR 4,910,435	03/1990	WAKALOPULOS			
hn	BR 5,215,636	06/1993	DANILYCHEV et al.			

FOREIGN PATENT DOCUMENTS

		Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract		Translation Readily Available	
						Enclosed	No	Enclose	No
hn	OR	05/156054	06/1993	Japan	ARAI et al.	X			
hn	PR	63/168440	07/1988	Japan	KOJI et al.	X			

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

hn	YR	JOZWIAK, H., "Electron beam curing of laquer coatings", Polim. Tworz. Wielk., 08/1985, pp 316-319.	X		
hn	ZR	IKADA, Y., "Comparison of surface modification of polymers by different methods", Radiation Physics and Chemistry, 06/1992, pp 509-511.	X		
hn	AAR	ANDO, M., "Synthesis of polymer materials by low energy electron beam", Polymer, 11/1988, pp 2136-2140.	X		
hn	BBR	NHO, Y.C., "Radiation-induced graft polymerisation of vinyl benzyltrimethylammonium chloride onto polyethylene film", J. Appl. Polym. Sci., 02/1994, pp 1269-1275.	X		
hn	CCR	RANBY, B., "Surface modification of polypropylene fibers by photoinitiated grafting", Polymer Preprints, Division of Polymer Chemistry, ACS Vol. 31, 1990, pp 446-447.	X		
hn	DDR	SIPERKO, L.M., "Chemical and physical modification of fluoropolymer surfaces for adhesion enhancement: a review", J. Adhes. Sci. Technol., 1989, pp 157-173.	X		
hn	EER	SETO, J., "Electron beam curing of acrylic oligomers", Kobunshi Ronbun, 1983, pp 9-15.	X		
hn	FFR	DAVIDSON, R.S., "Electron beam curing of dialkyltin diacrylates", Polymer, 1992, pp 1836-1842.	X		
hn	GGR	NO AUTHOR, "Electron beam curing system", Plast. Engng., 09/1987, p. 64.	X		
hn	HHR	NO AUTHOR, "Electron beam curing", Rubber World, 12/1987, p. 49.	X		
hn	IIR	VROOMEN, G.L.M., "Electron beam curing of EPDM", Rubber World, 11/1991, pp 23-32.			
hn	JJR	JOHNSON, M.A., "Effects of electron beam dosage on cured homopolymer properties of acrylate oligomers", RadTech '90 - North America Conference Papers, 1990, pp 71-79.			
hn	KKR	DELANEY, W.H., "The versatility of electron beam contract processing: releases, PSA, cross-linking, grafting and cationic curing", RadTech '90 - North America Conference Papers, 1990, pp 103-108.			
hn	LLR	ALLEN, N.S., "Photooxidative stability of electron beam and UV-cured acrylated epoxy and urethane acrylate resin films", Polym. Degradat. Stabil., 1987, pp 147-160.	X		
hn	MMR	NO AUTHOR, "Electron beam curing system", Adhesives Age, 03/1993, p. 22.	X		
hn	NNR				
hn	OOR				
hn	PPR				

Examiner

Harry Ngo

Date Considered:

11/27/00

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 909. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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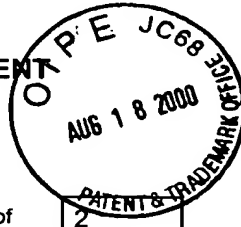
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	KR					
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	QR									
	RR									
	SR									
	TR									
	UR									
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ln	JJR	WEISS, D.E., "Electron beam modification of polymer film properties", RadTech '92 - North America Conference Papers, 1992, pp 687-696.	X			
ln	KKR	WYBOURNE, M.N., "Modification of polymer surfaces and the fabrication of submicron-scale functionalized structures by deep-ultraviolet and electron-beam lithography", J. Vac. Sci. Technol., 1993, pp 2210-2213.	X			
ln	AAR	HACKER, N.P., "New reactions of cationic photoinitiators", Radiation Curing in Polymer Science and Technology - Vol. 2: Photoinitiating Systems, 1993, pp 473-504.				
	BBR					
	CCR					

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*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.